



Attorney's Doc#

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#9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ilya Perlov et al.

Art Unit : 3723

Serial No. : 09/507,172

Examiner : Timothy V. Eley

Filed : February 18, 2000

Title : CHEMICAL MECHANICAL POLISHING SYSTEM HAVING MULTIPLE  
POLISHING STATIONS AND PROVIDING RELATIVE LINEAR MOTION

Commissioner for Patents  
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the action mailed May 22, 2001, applicant elects the invention of Group I,  
drawn to an apparatus (claims 1-11, 19-26, 29-31 and 36-37). The election is made without  
traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

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JAN 28 2002

Date: 12/11/01

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